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**Date of Patent:** 

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[45]

## United States Patent [19]

### Kawamata et al.

### [54] PROCESS FOR PRODUCING THIN FILM

- [75] Inventors: Ken Kawamata; Nobuaki Mitamura, both of Hachioji, Japan
- [73] Assignee: Olympus Optical Co., Ltd., Japan
- [21] Appl. No.: 08/683,195
- [22] Filed: Jul. 18, 1996

#### [30] Foreign Application Priority Data

Jul. 20, 1995 [JP] Japan ...... 7-184454

- [51] Int. Cl.<sup>6</sup> ...... C22C 23/00
- [52] U.S. Cl. ..... 148/420; 420/402; 359/580;
- 204/192.12; 204/192.26; 204/192.29; 204/298.09

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Primary Examiner-Nam Nguyen

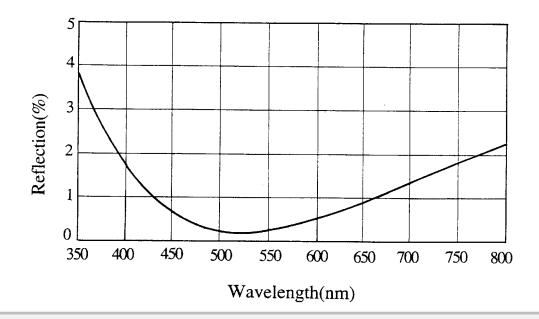
Assistant Examiner-Steven H. VerSteeg

Attorney, Agent, or Firm—Ostrolenk, Faber, Gerb & Soffen, LLP

### [57] ABSTRACT

A substrate (2) is rotatably installed in a vacuum chamber (1) at an upper part thereof  $MgF_2$  granules (3) as a film source material are placed in a quartz boat (4) and mounted on a magnetron cathode (5). The magnetron cathode (5) is connected through a matching box (6) to a 13.56 MHz radio frequency power source (7). Cooling water (8) for holding the temperature of the magnetron cathode (5) constant flows against a lower face of the magnetron cathode (5). A side wall of the vacuum chamber (1) is provided with gas introduction ports (9), (10) for introducing gas in the vacuum chamber (1). A shutter (11) is placed between the magnetron cathode (5) and the substrate (2). This structure provides a process enabling forming a thin film at a high speed by sputtering, especially a high speed sputtering process enabling forming a thin fluoride film free of light absorption.

### 11 Claims, 10 Drawing Sheets



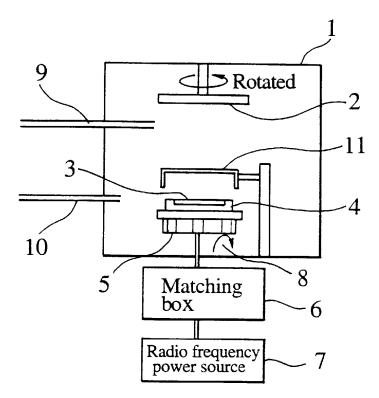
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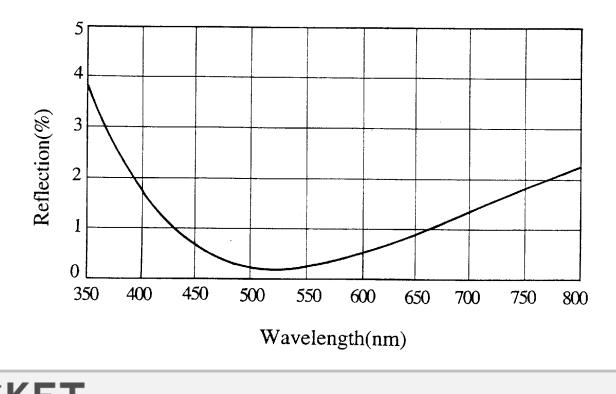
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# FIG.3



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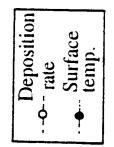


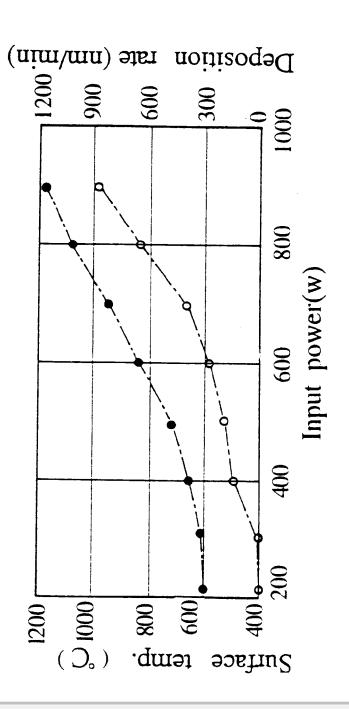
FIG.2

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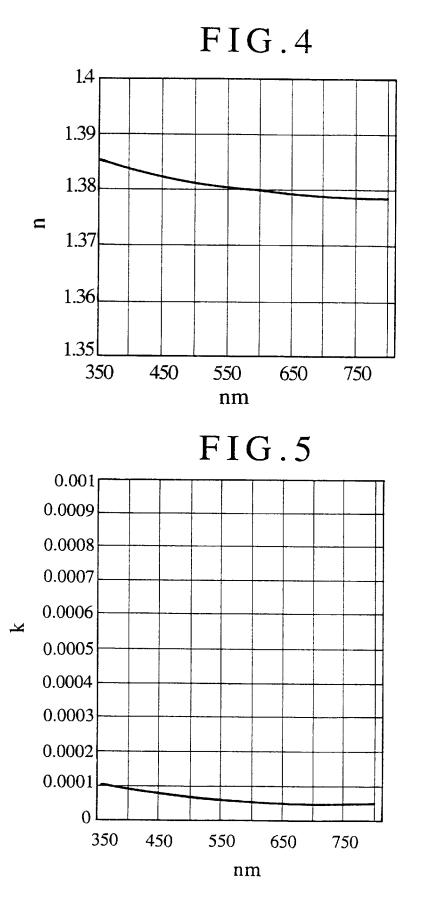
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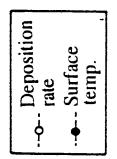


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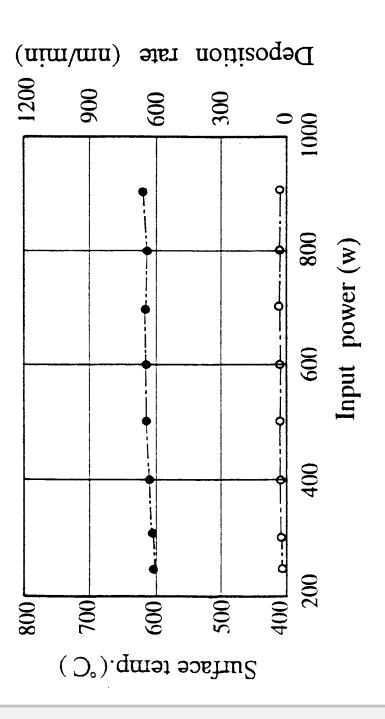
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